

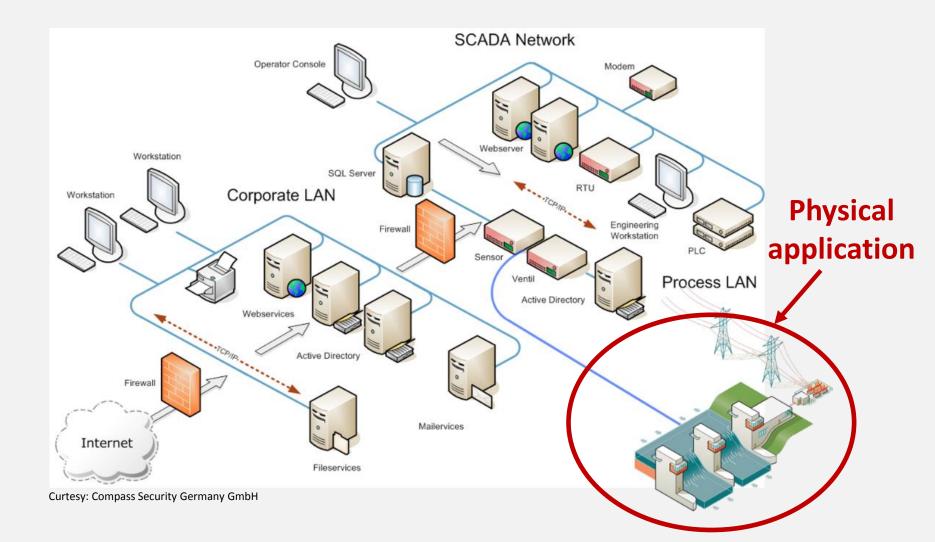
Rocking the Pocket Book: Hacking Chemical Plants for Competition and Extortion

Marina Krotofil

Black Hat, Las Vegas, USA 06.08.2015



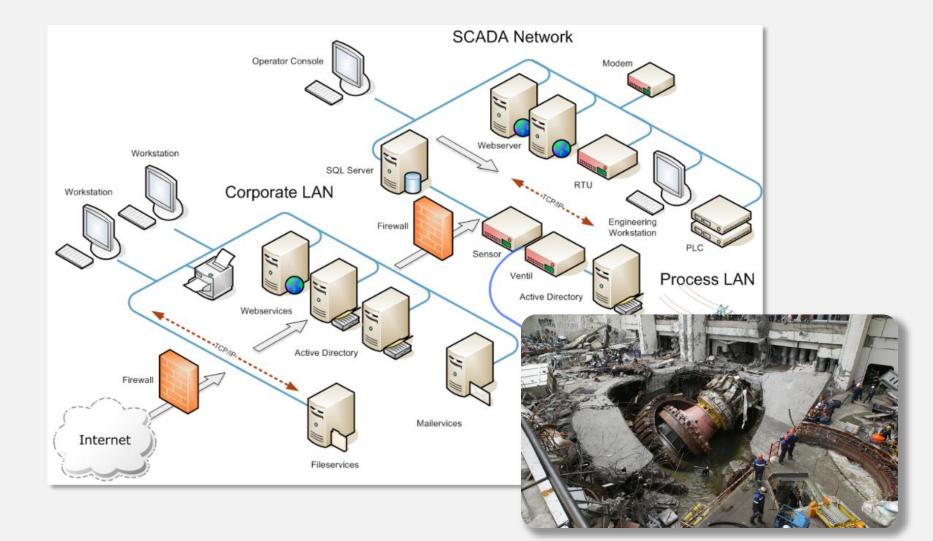
Industrial Control Systems (aka SCADA)





Cyber-physical systems are IT systems "embedded" in an application in the physical world Interest of the attacker is in the physical world

Industrial Control Systems





- Complex continuous processes (e.g. chemical plants)
- Non-opportunistic attacker
- I do not research into (but consider) cyber vulnerabilities in communication protocols and control equipment
- What the attacker can do to the process?
- What she needs to do and why?
- What needs to be programmed into a final payload?
- Are traditional cyber-security measures adequate?



Control systems hacking

Ralph Langner: "The pro's don't bother with vulnerabilities; they use features to compromise the ICS"





Security is not a fundamental science It is application driven

Security solutions exist in the context of the application

Early adopter: E-commerce

Security influences design decisions

- Attackers (mis)use functionality of web browsers
- Novel approaches to designing web applications
- Novel security controls in browsers

Application dictates security properties

- Information-theoretic security properties
- CIA triad → Parkerian hexad

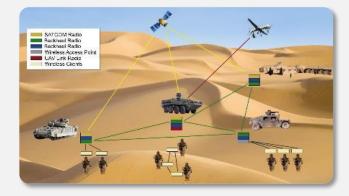




Failed to adopt

Wireless sensor networks

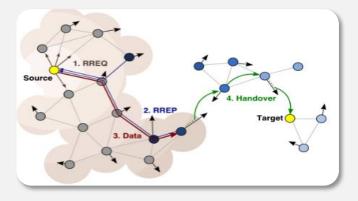
- A big hype for about a decade
- Conferences, solutions, promising applications



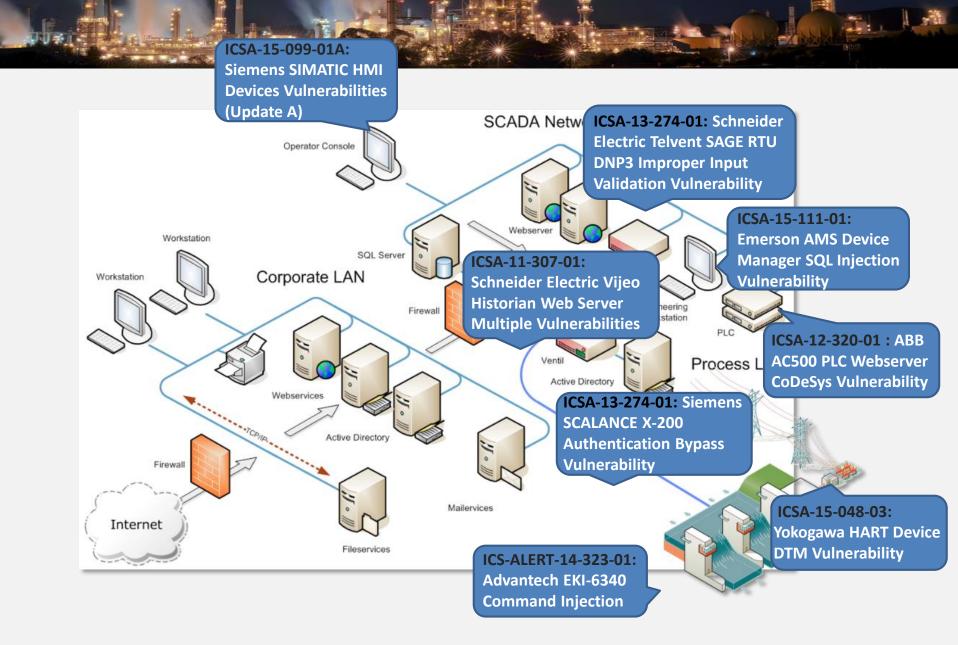
Remained a "promising" technology with limited deployment

Downfall reasons

- Deficiencies in the attacker models and security requirements
- Unrealistic assumptions about physics of wireless communication



Control equipment vulnerabilities



ICS-CERT recommendation

ICSA-13-274-01: Siemens SCALANCE X-200 Authentication Bypass Vulnerability

IMPACT

Successful exploitation of this vulnerability may allow attackers to perform administrative operations over the network without authentication.

Impact to individual organizations depends on many factors that are unique to each organization. ICS-CERT recommends that organizations evaluate the impact of this vulnerability based on their operational environment, architecture, and product implementation.





- What exactly the attacker can do with the vulnerability?
- Any further necessary conditions required?
- □ How severe the potential physical impact?

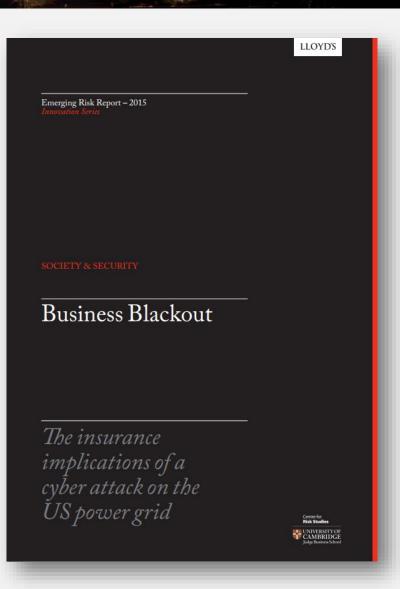


Answering these questions requires understanding how the attacker interacts with the control system and the process

Incident data unavailability

- Due to various schemes for reputation management and data sharing laws, the majority of Operational Technology attacks over the last 20 years have not been made public, making even a catalogue of recent reference events difficult to assemble.
- A key requirement for an insurance response to cyber risks will be to enhance the quality of data available and to continue the development of probabilistic modelling.

We can and should conduct own research on cyber-physical exploitation



Control systems security

Control system design flaw



Industrial systems can be controlled without modifying the contents of the messages

 Can be effective even if the traffic is signed or even encrypted

Overlooked data security property

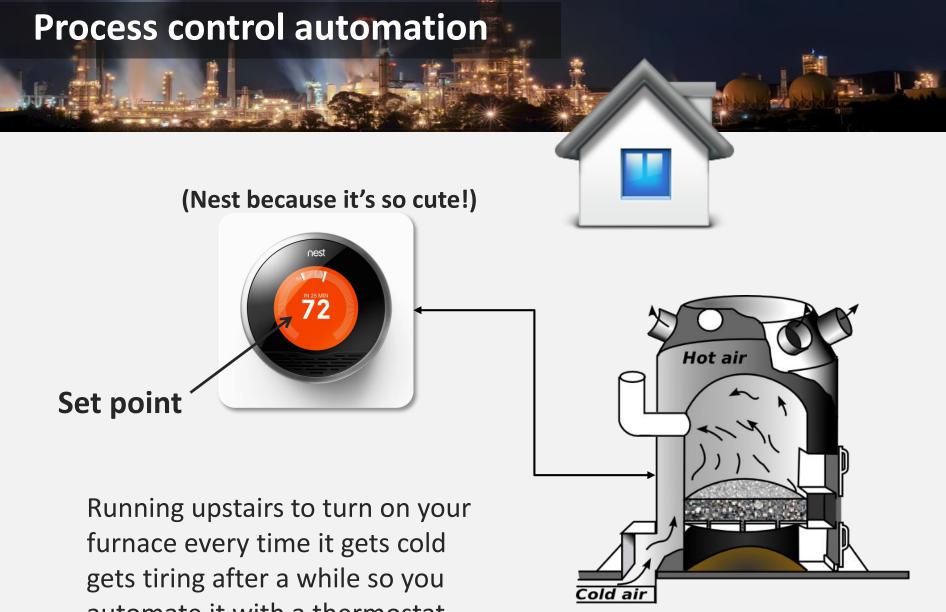


 Can be done despite all traditional communication security put in place

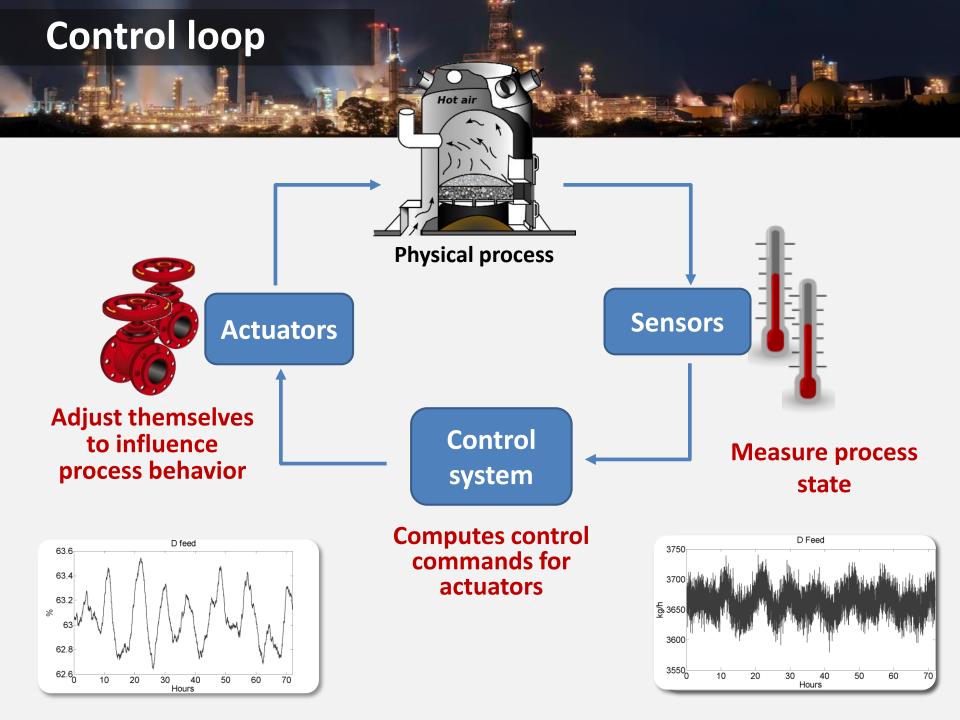
M. Krotofil, J. Larsen. What You Always Wanted and Now Can: Hacking Chemical Processes. Hack in the Box, Amsterdam (2015)

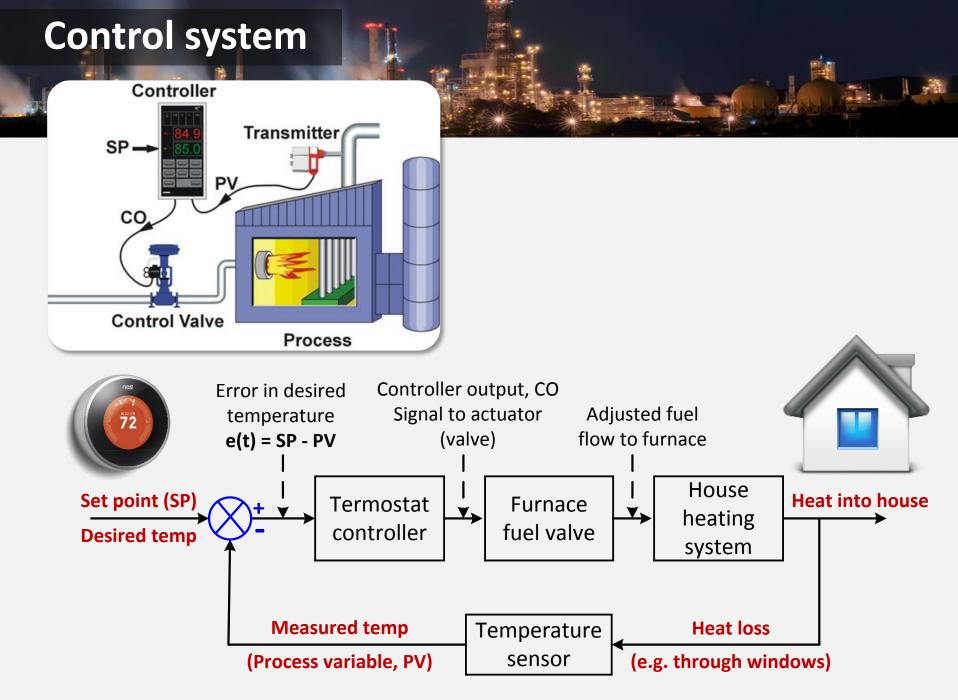


Process control



automate it with a thermostat





Control equipment

- In large-scale operations control logic gets more complex than a thermostat
- One would need something bigger to handle it all
- Most of the time this is a programmable logic controller (PLC)







1. Copy data from inputs to temporary storage

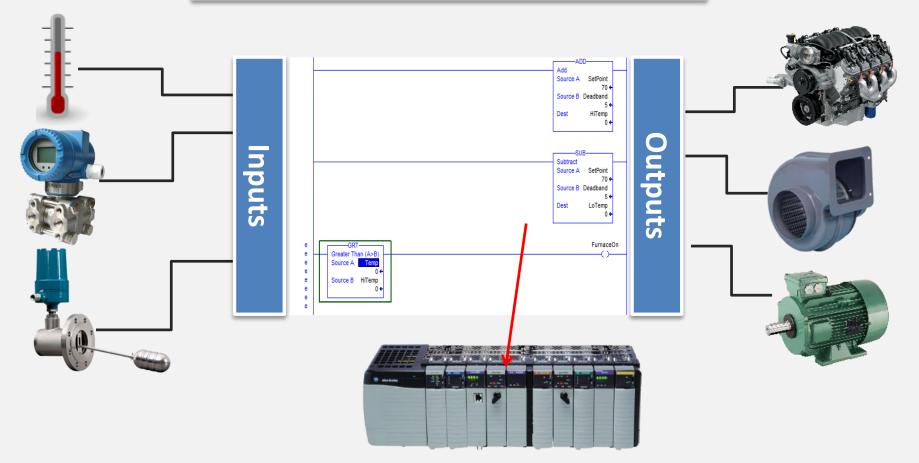
Copy from temporary storage to outputs

2. Run the logic

3.

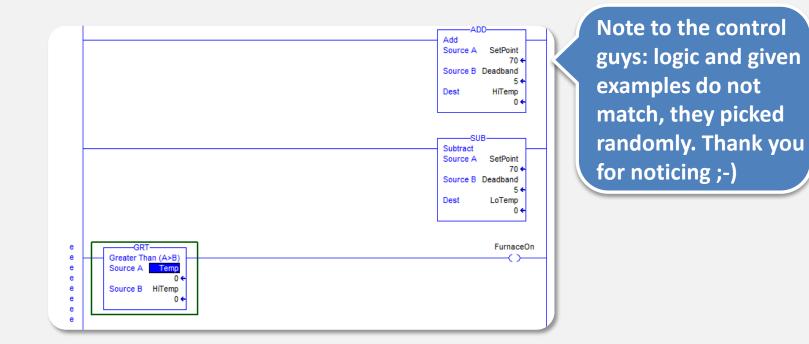
Sensors

Actuators





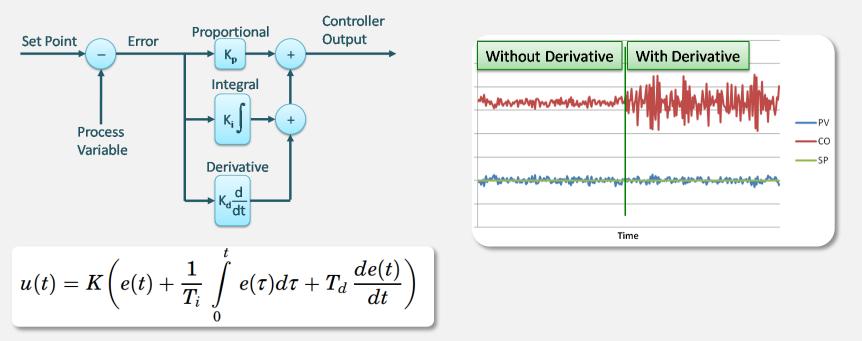
It is programmed graphically most of the time



If Input 1 and (Input 4 or Input 11) then Output 6

If tank pressure in PLC 1 > 1800 reduce inflow in PLC 3





- PID: proportional, integral, derivative most widely used control algorithm on the planet
- The sum of 3 components makes the final control signal
- PI controllers are most often used

Field communication

Communication media

- o 4-20 mA
- o 0-10 v
- Air pressure

Usually process values are scaled into meaningful data in the PLC



Wires are run from sensors and actuators into wiring cabinets



- PLC does not have the complete picture and time trends
- Human operators watch the process 7/24
- Most crucial task: resolution of alarms





SCADA hacking



Industry means big business Big business == \$\$\$\$\$\$\$





Industry means big business Big business == \$\$\$\$\$\$\$

Alan Paller of SANS (2008):

In the past two years, hackers have successfully penetrated and extorted multiple utility companies that use SCADA systems.

Hundreds of millions of dollars have been extorted, and possibly more. It's difficult to know, because they pay to keep it a secret. **This kind of extortion is the biggest untold story of the cybercrime industry.**

Why to attack ICS



Attack goal: persistent economic damage

Here's a plant. What is the plan?



What can be done to the process

Equipment damage	Production damage	Compliance violation
 Equipment overstress Violation of safety limits 	 Product quality and product rate Operating costs Maintenance efforts 	 Safety Pollution Contractual agreements

Paracetamol



	Purity	Relative price, EUR/kg	
STO .	98%	1	
1	99%	5	
	100%	8205	
P ,+			

Source: http://www.sigmaaldrich.com/



Attack considerations

Equipment damage

- Comes first into anybody's mind (+)
- o Irreversible (∓)
- Unclear collateral damage (-)
- May transform into compliance violation, e.g. if it kills human (-)

Compliance violation

- Compliance regulations are public knowledge (+)
- Unclear collateral damage (-)
- Must be reported to the authorities (7)
- Will be investigated by the responsible agencies (-)

Equipment damage

Production damage

Compliance violation

Plants for sale

From LinkedIn



Used VAM - Vinyl Acetate Monomer plant for sale & relocation! If any interest, please contact me!

+ Follow Tommy

Tommy Heino Industrialist & Entrepreneur, Owner, XHL Business Engineering **Top Contributor**

Like · Comment (4) · Share · Follow · 3 mor

More plants offers: http://www.usedplants.com/





It is not about the size

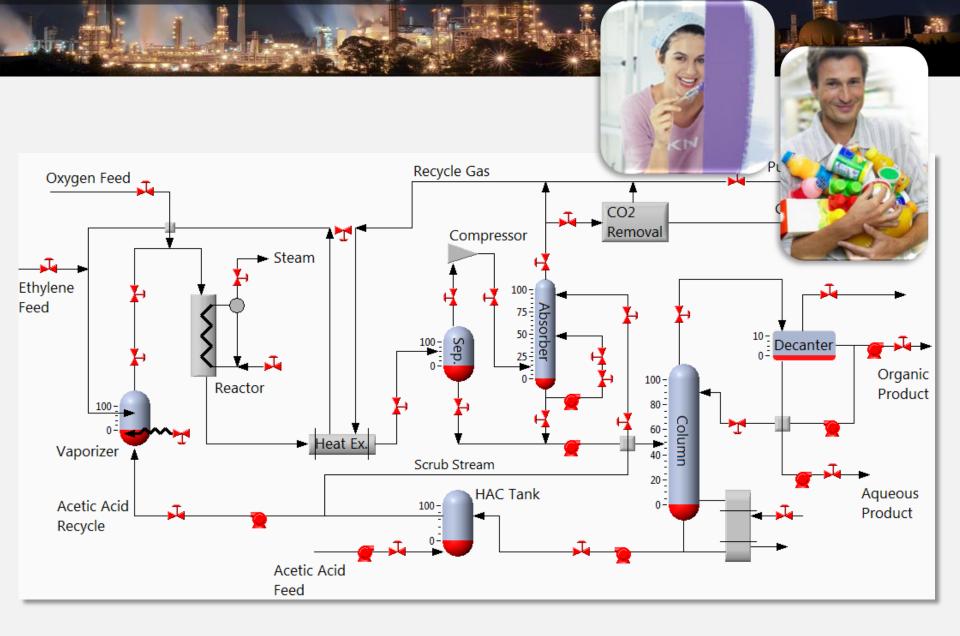






It is about MONEY Plants are ouch! how expensive

Vinyl Acetate Monomer plant (model)







Behind great woman is a great man

Acknowledgement

Process Automation Consultant



Student



Cyber-physical hacker



Chemical Engineer



Programmer



Acknowledgement

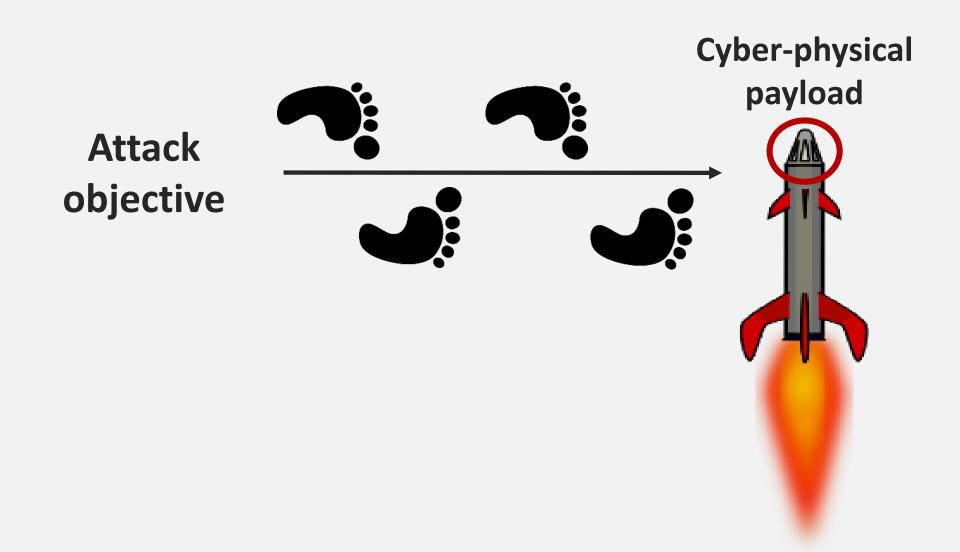
- Alexander Isakov awesome software engineer
- Alexander Winnicki very good student
- Dieter Gollmann most supportive professor
- Jason Larsen cyber-physical hacking guru
- Pavel Gurikov chemical engineer who believes in hackers
- □ William Horner experienced automation expert

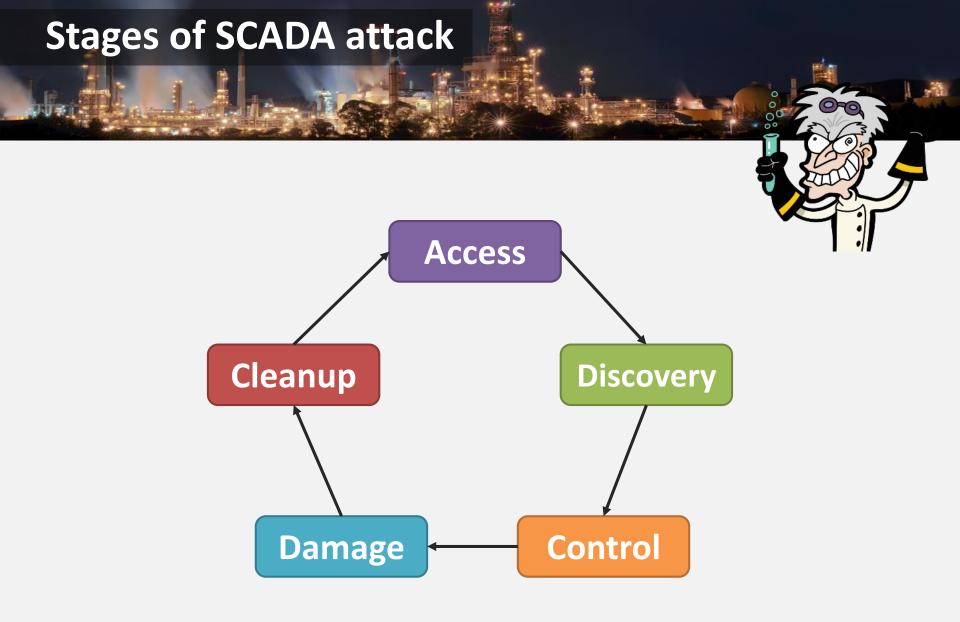




Stages of cyber-physical attacks

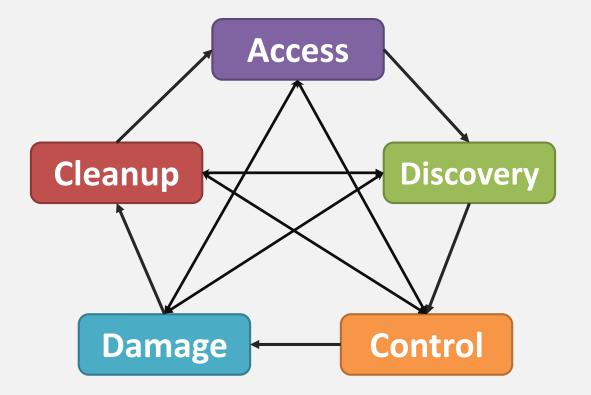


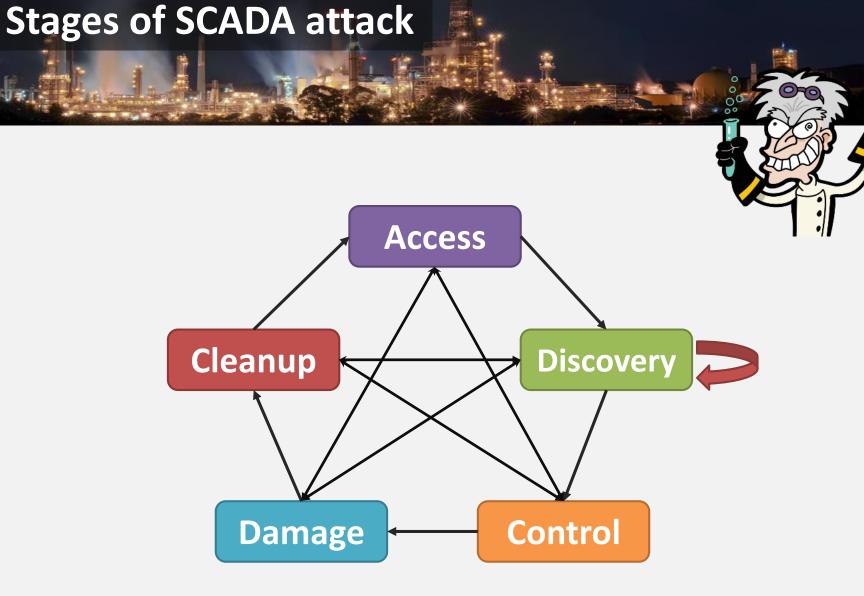




J. Larsen. Breakage. Black Hat Federal (2007)

Stages of SCADA attack



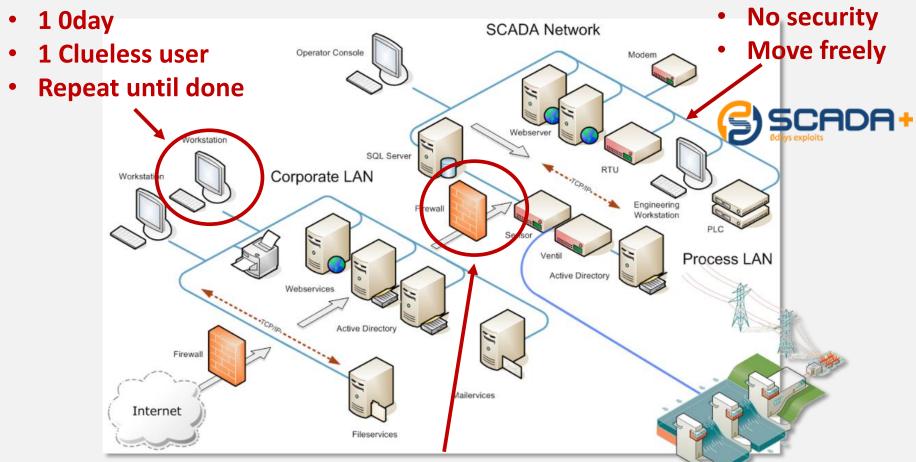


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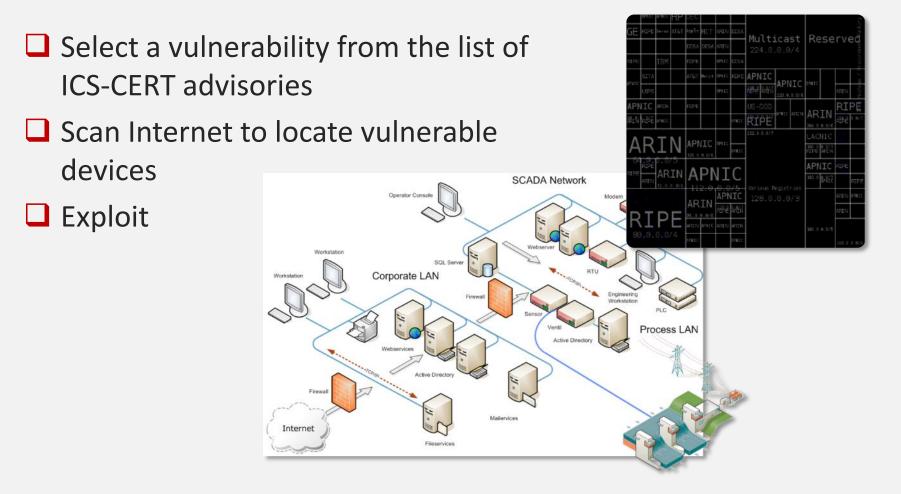
Access

Traditional IT hacking



- AntiVirus and Patch Management
- Database links
- Backup systems

Modern IT hacking

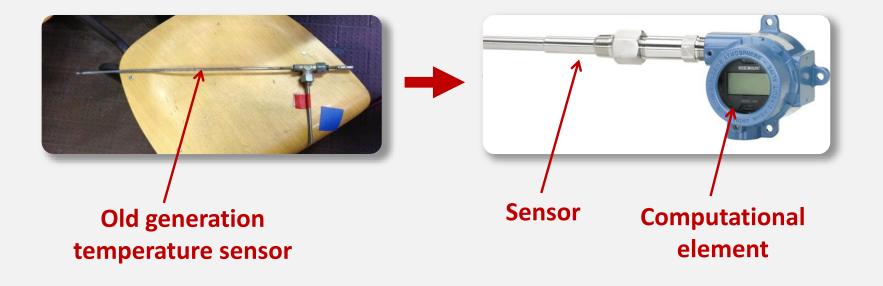


- E. Leverett, R. Wightman. Vulnerability Inheritance in Programmable Logic Controllers (GreHack'13)
- D. Beresford. Exploiting Siemens Simatic S7 PLCs . Black Hat USA (2011)

Plants modernization

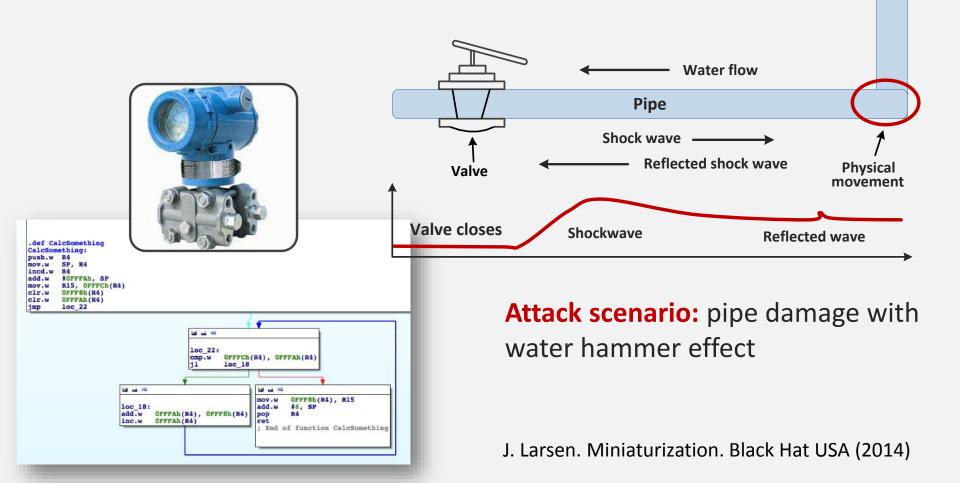
Smart instrumentation

- Converts analog signal into digital
- Sensors pre-process the measurements
- o IP-enabled (part of the "Internet-of-Things")





Inserting rootkit into sensor's firmware

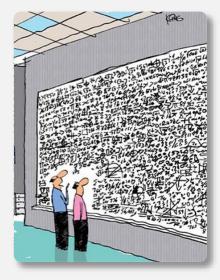


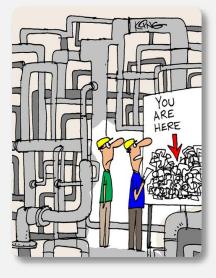


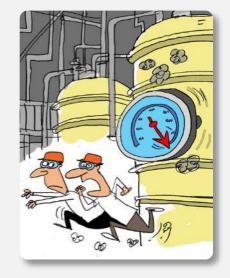
Discovery

Process discovery









What and how the process is producing

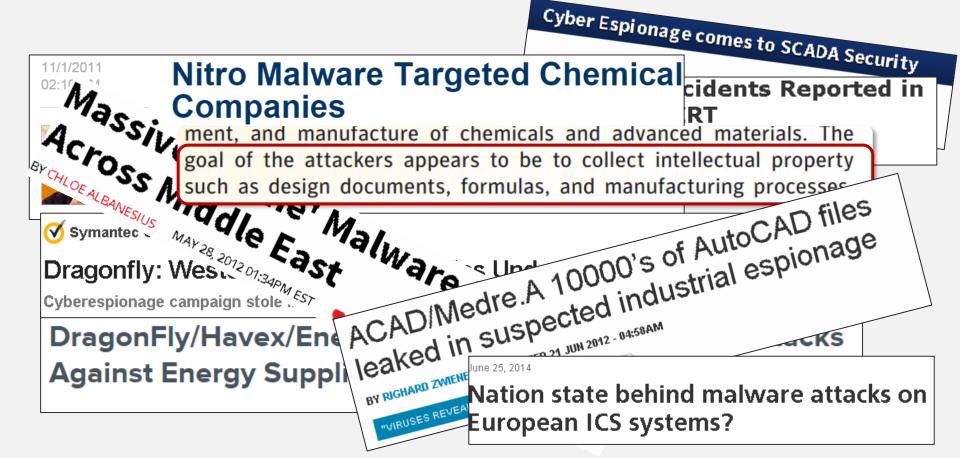
How it is controlled

How it is build and wired Operating and safety constraints

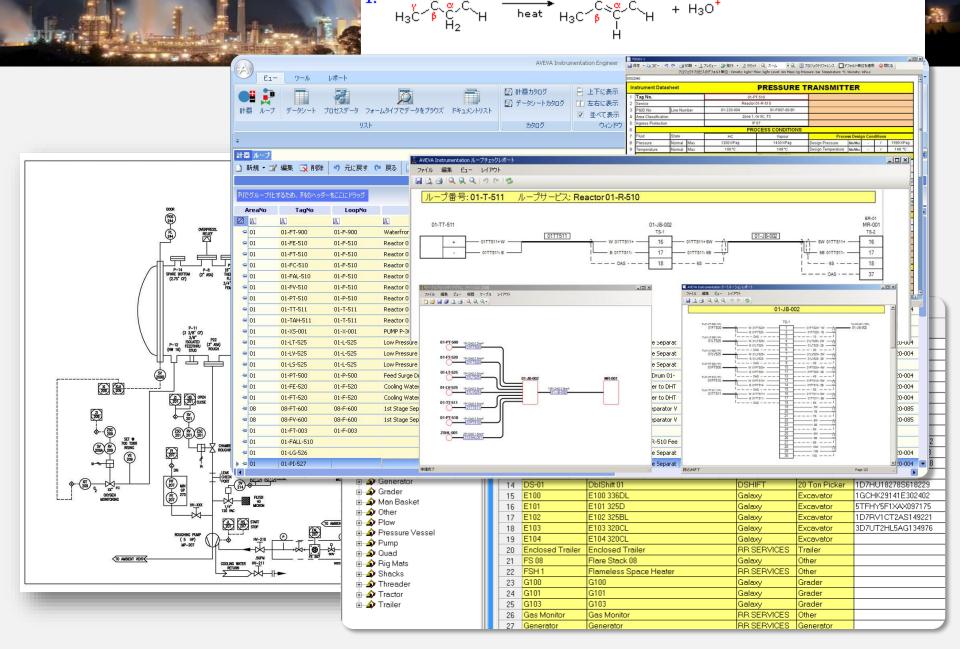
Espionage, reconnaissance Target plant and third parties



Industrial espionage has started LONG time ago (malware samples dated as early as 2003)



Process discovery



H-O

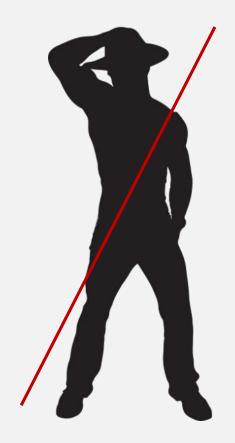
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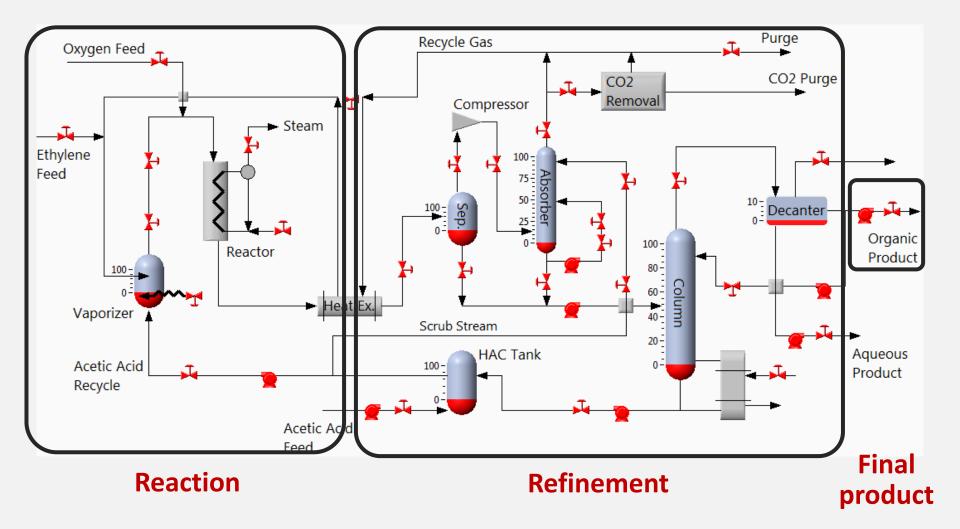
Stripper is...



Stripping column



Max economic damage?

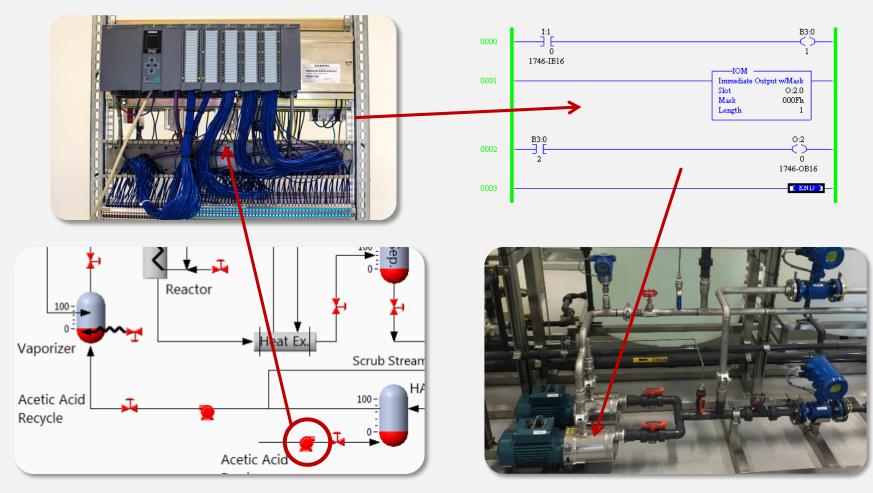


Requires input of subject matter experts

Understanding points and logic

Programmable Logic Controller

Ladder logic

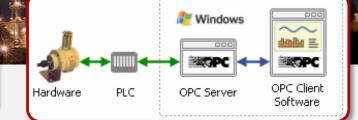


Piping and instrumentation diagram

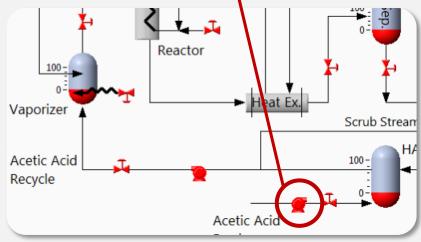
Pump in the plant

Understanding points and logic

HAVEX: Using OPC, the malware component gathers any details about connected devices and sends them back to the C&C.

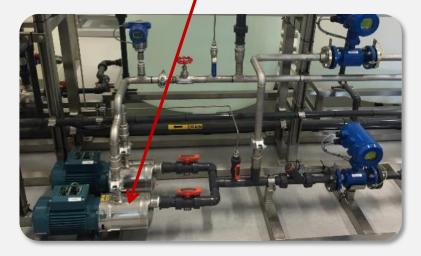






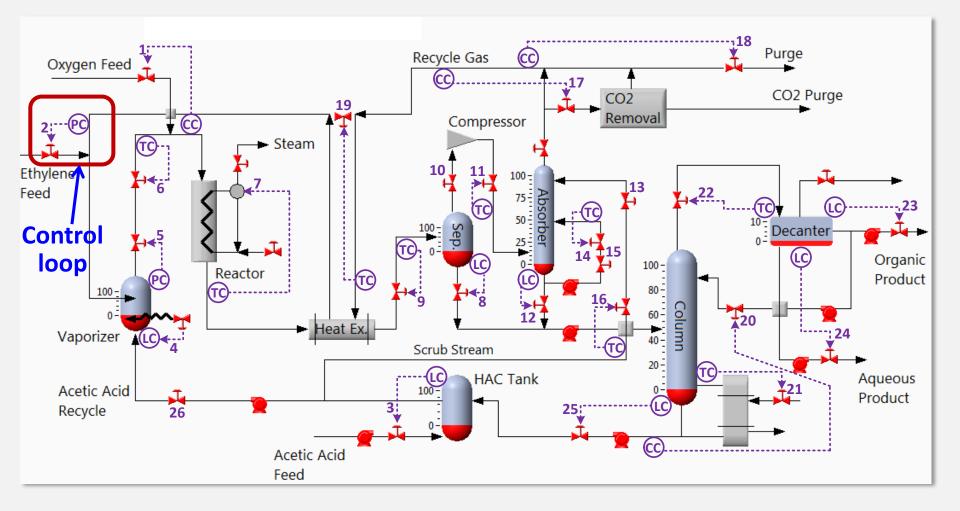
Piping and instrumentation diagram





Pump in the plant

Understanding control structure



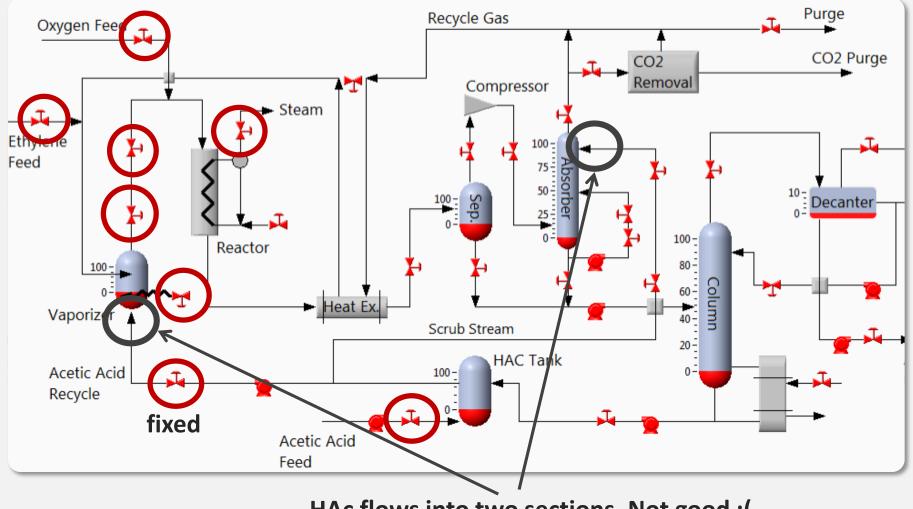
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Turkey!

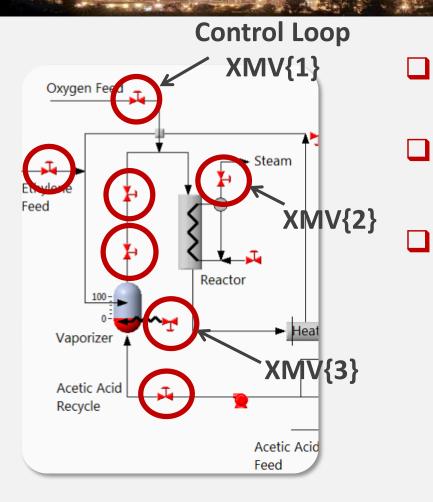
AVEVADefault (27 Records)

Watch the flows!



HAc flows into two sections. Not good :(

Obtaining control != being in control



Obtained controls might not be useful for attack goal

How do I even speak to this thing??

K. Wilhoit, S. Hilt. The little pump gauge that could: Attacks against gas pump monitoring systems. Black Hat (2015)

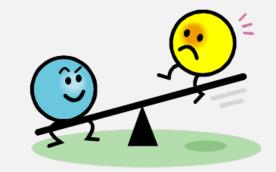
Attacker might not necessary be able to control obtained controls

Huh ???





Control



Every action has a reaction

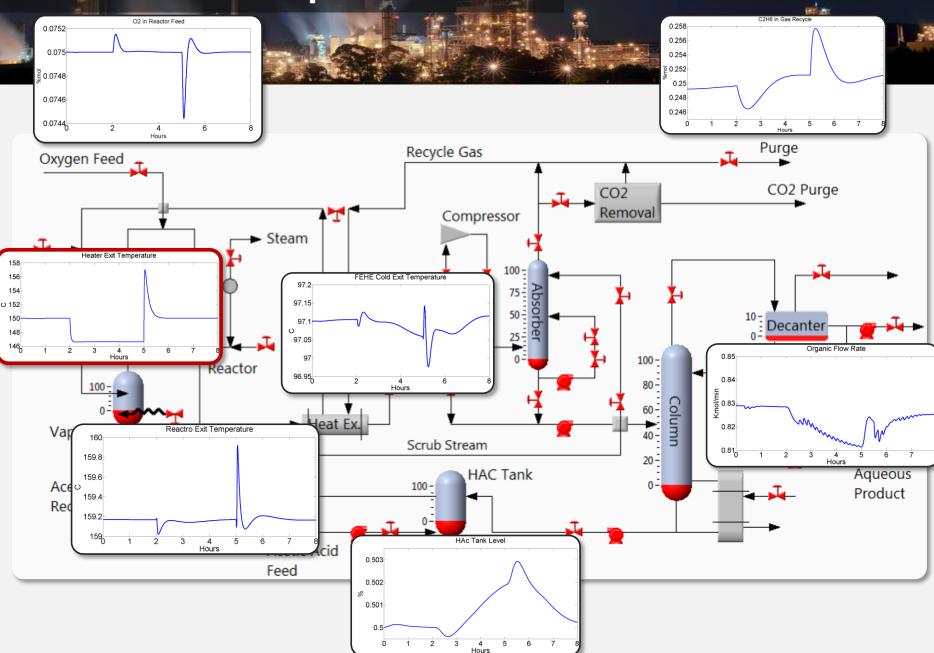
Physics of process control

- Once hooked up together, physical components become related to each other by the physics of the process
- If we adjust a valve what happens to everything else?
 - Adjusting temperature also increases pressure and flow

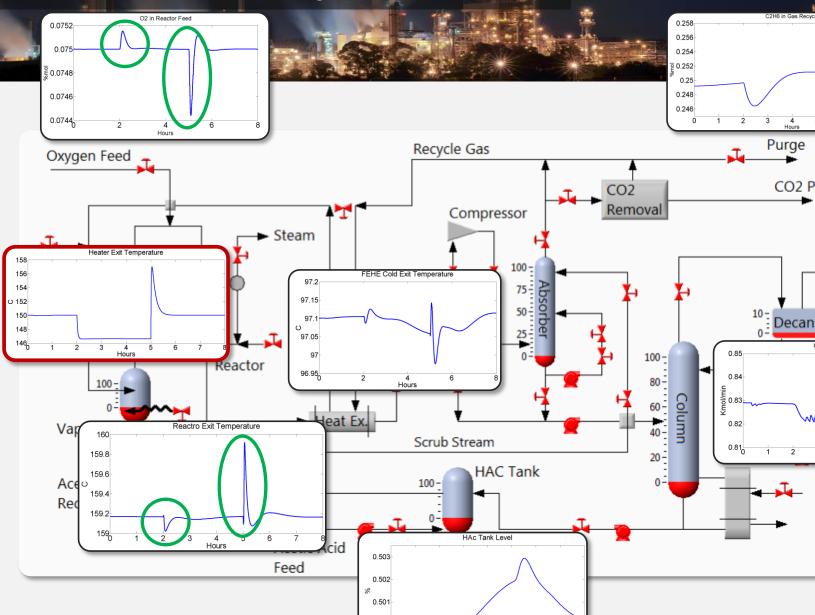


- All the downstream effects need to be taken into account
- How much does the process can be changed before releasing alarms or it shutting down?

Process interdependencies



Process interdependencies



0.5

Hours

HE SH

Hours

CO2 Purge

Decanter

Hours

Organic Flow Rate

Aqueous

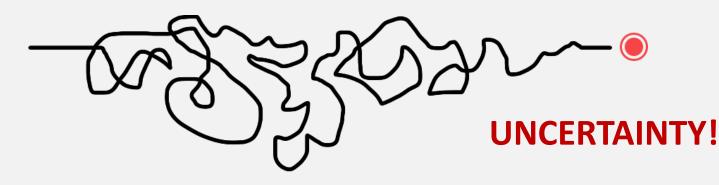
Product

Understanding process response i si • Sizing • Equipment design • Dead band • Process design • Flow properties Control loops coupling • Control algorithm • Controller tuning • Operating practice Control strategy Set point **Final control** Controller Process element Disturbance • Type Duration Transmitter Sampling frequency • Noise profile • Filtering

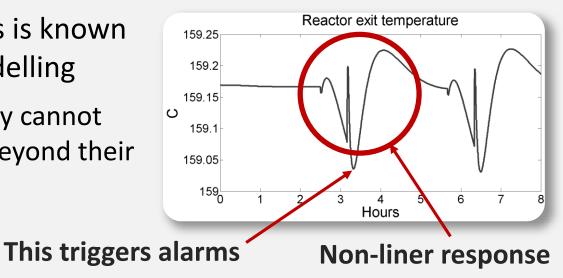
Understanding process response i si • Sizing • Equipment design • Dead band • Process design • Flow properties Control loops coupling • Control algorithm • Controller tuning • Operating practice Control strategy Set point **Final control** Controller Process element Disturbance • Type Duration Transmitter • Sampling frequency • Noise profile • Filtering Have extensively studied

Process control challenges

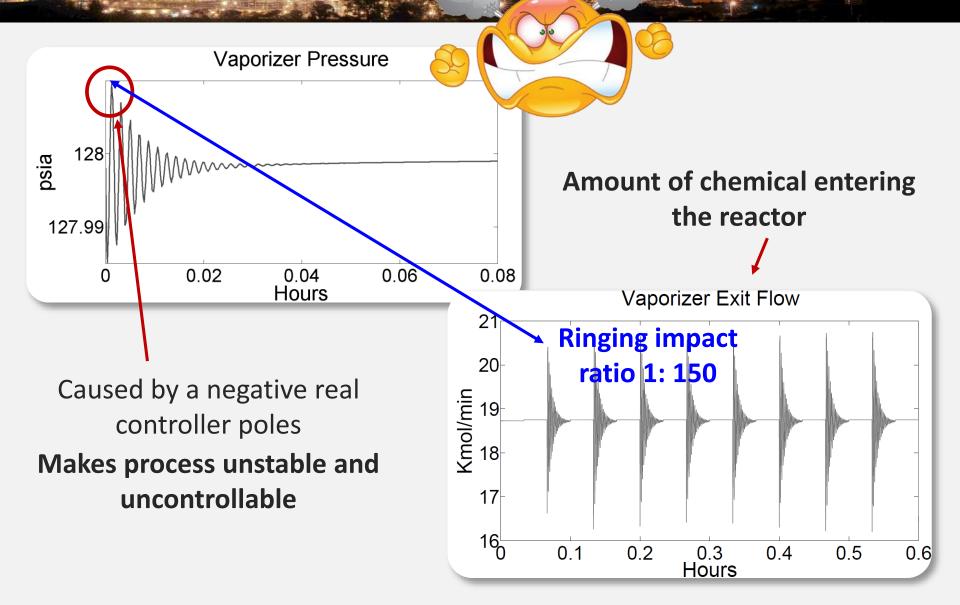
Process dynamic is highly non-linear (???)



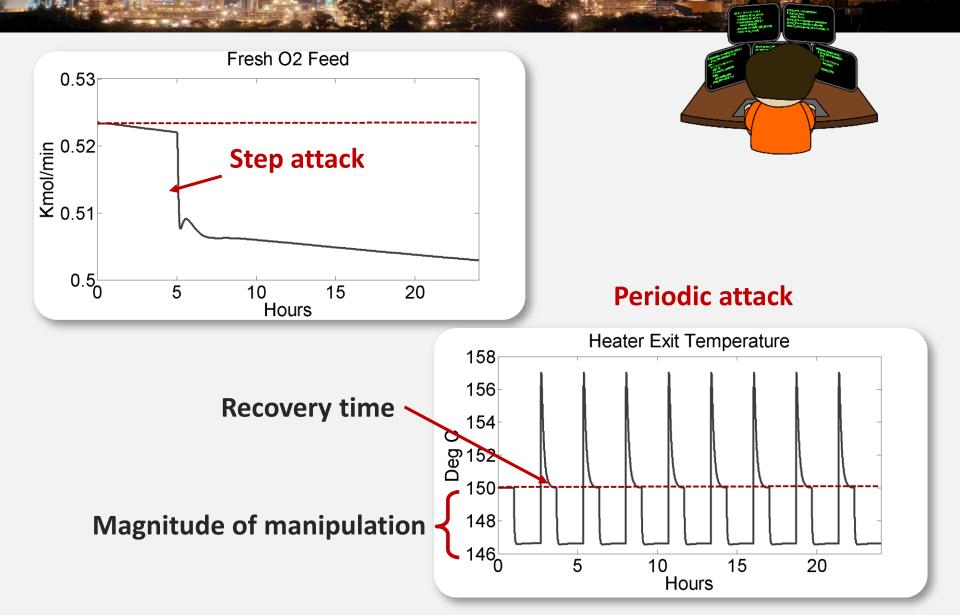
- Behavior of the process is known to the extent of its modelling
 - So to controllers. They cannot control the process beyond their control model



Control loop ringing



Types of attacks



Outcome of the control stage



I am 5'3" tall

We should probably automate this process (work in progress)



Outcome of the control stage

Sensitivity	Magnitude of manipulation	Recovery time			
High	XMV {1;5;7}	XMV {4;7}			
Medium	XMV {2;4;6}	XMV {5}			
Low	XMV{3}	XMV {1;2;3;6}			
Reliably useful controls					



To persist we shall not bring about alarms

Alarm	Steady state attacks	Periodic attacks
Gas loop 02	XMV {1}	XMV {1}
Reactor feed T	XMV {6}	XMV {6}
Rector T	XMV{7}	XMV{7}
FEHE effluent	XMV{7}	XMV{7}
Gas loop P	XMV{2;3;6}	XMV{2;3;6}
HAc in decanter	XMV{2;3;7}	XMV{3}

The attacker needs to figure out the marginal attack parameters which (do not) trigger alarms



Damage



Attacker needs one or more attack scenarios to deploy in final payload

- The least familiar stage to IT hackers
 - In most cases requires input of subject matter experts
- Accident data is a good starting point
 - o Governmental agencies
 - Plants' own data bases







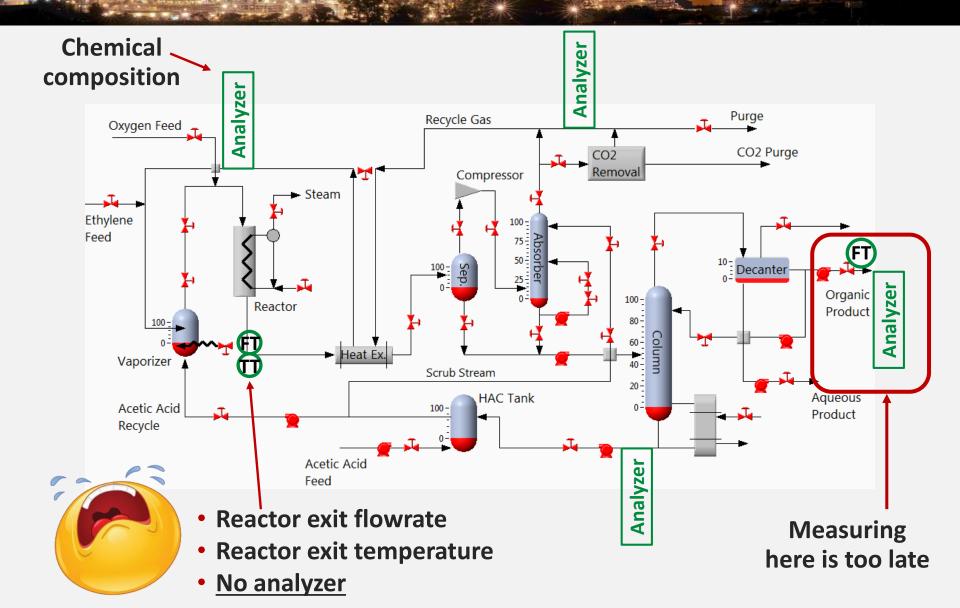
Hacker unfriendly process

Target plant may not have been designed in a hacker friendly way

- There may no sensors measuring exact values needed for the attack execution
- The information about the process may spread across several subsystems making hacker invading more devices
- Control loops may be designed to control different parameters that the attacker needs to control for her goal



Measuring the process





If you can't measure it, you can't manage it Peter Drucker



Technician vs. engineer

Technician

"It will eventually drain with the lowest holes loosing pressure last"

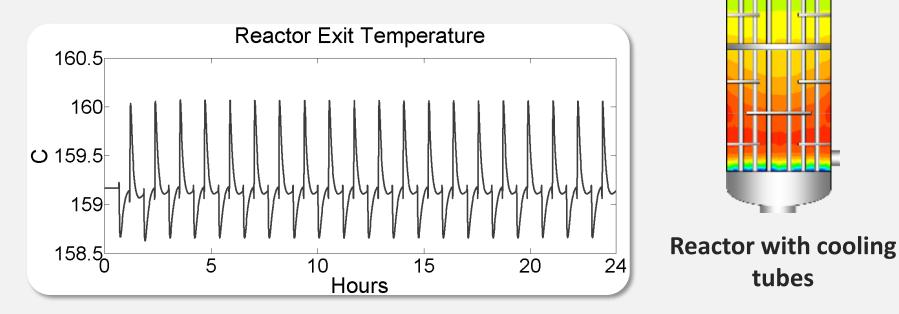


Engineer

"It will be fully drained in 20.4 seconds and the pressure curve looks like this"

Technician answer

Usage of proxy sensor



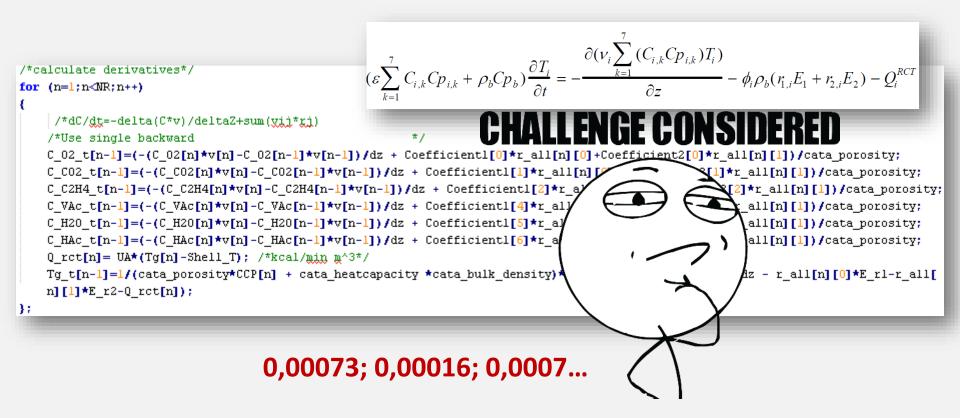
Only tells us whether reaction rate increases or decreases Is not precise enough to compare effectiveness of different attacks

tubes

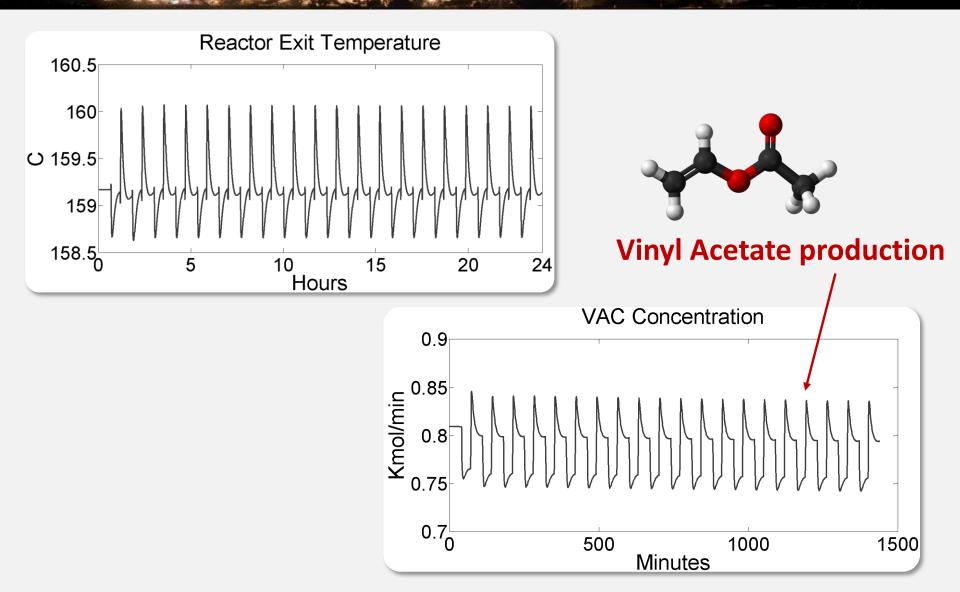
Quest for engineering answer

Code in the controller

- Optimization applications
- Test process/plant



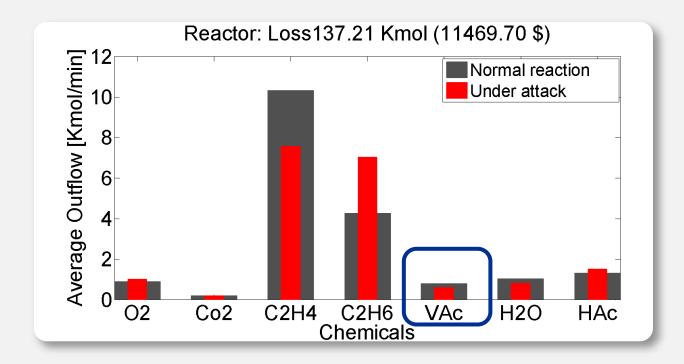
Engineering answer



Product loss

Product per day: 96.000\$

Product loss per day: 11.469,70\$



KPI

Outcome of the damage stage

Product per day: 96.000\$

Product loss, 24 hours	Steady-state attacks	Periodic attacks
High, ≥ 10.000\$	XMV {2}	XMV {4;6}
Medium, 5.000\$ - 10.000\$	XMV {6;7}	XMV {5;7}
Low, 2.000\$ - 5.000\$	-	XMV {2}
Negligible, ≤ 2.000\$	XMV {1;3}	XMV {1;2}

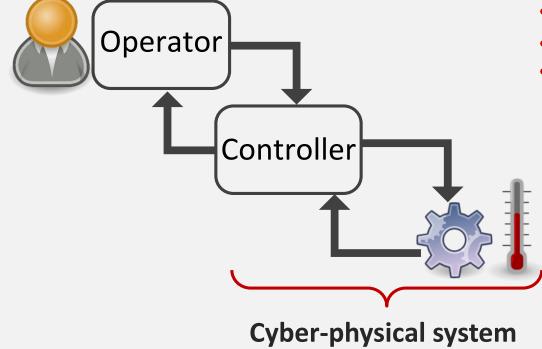
Still might be useful



Clean-up

Socio-technical system







- Maintenance stuff
- Plant engineers

. . . .

• Process engineers

Creating forensics footprint

- Process operators may get concerned after noticing persistent decrease in production and may try to fix the problem
- If attacks are timed to a particular employee shift or maintenance work, plant employee will be investigated rather than the process

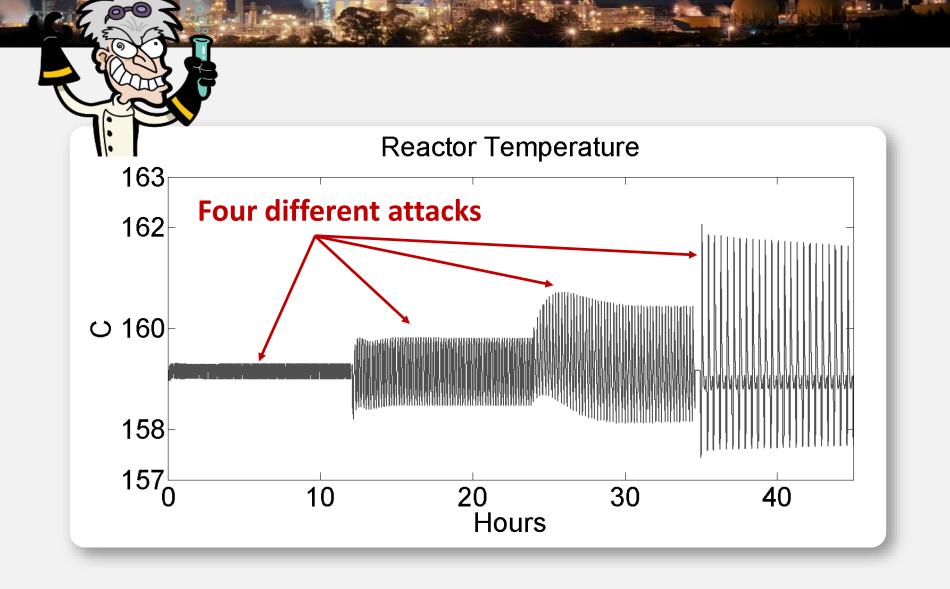


Creating forensics footprint

- 1. Pick several ways that the temperature can be increased
- 2. Wait for the scheduled instruments calibration
- 3. Perform the first attack
- Wait for the maintenance guy being yelled at and recalibration to be repeated
- 5. Play next attack
- 6. Go to 4

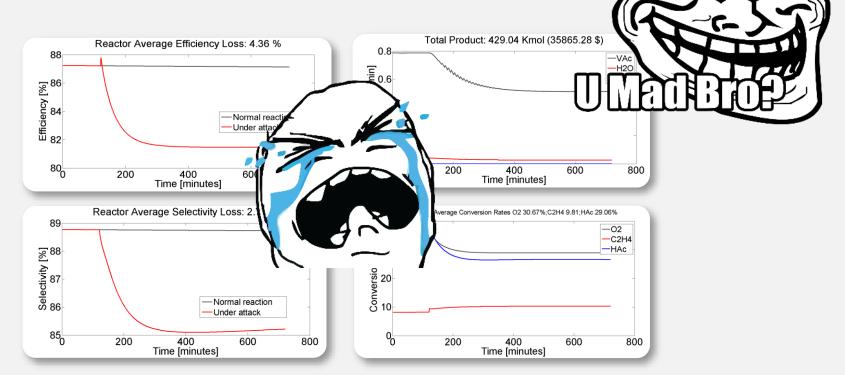


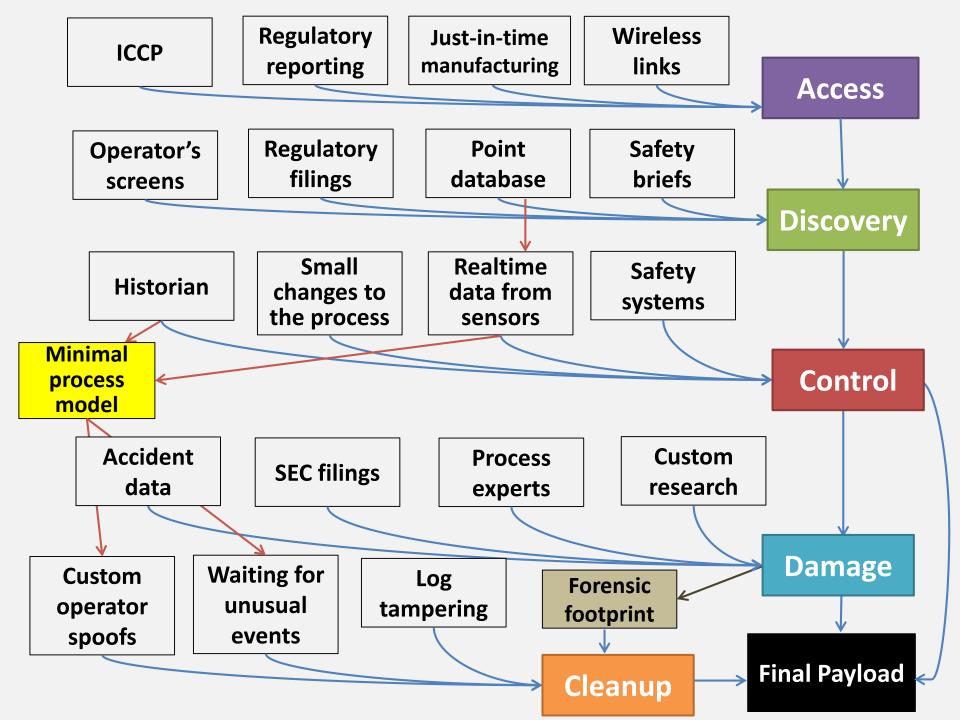
Creating forensics footprint



Defeating chemical forensics

- If reactor deemed malfunctioning, chemical forensics will be asked to assist
- Know metrics and methods of chemical investigators
- Change attack patterns according to debugging efforts of plant personnel

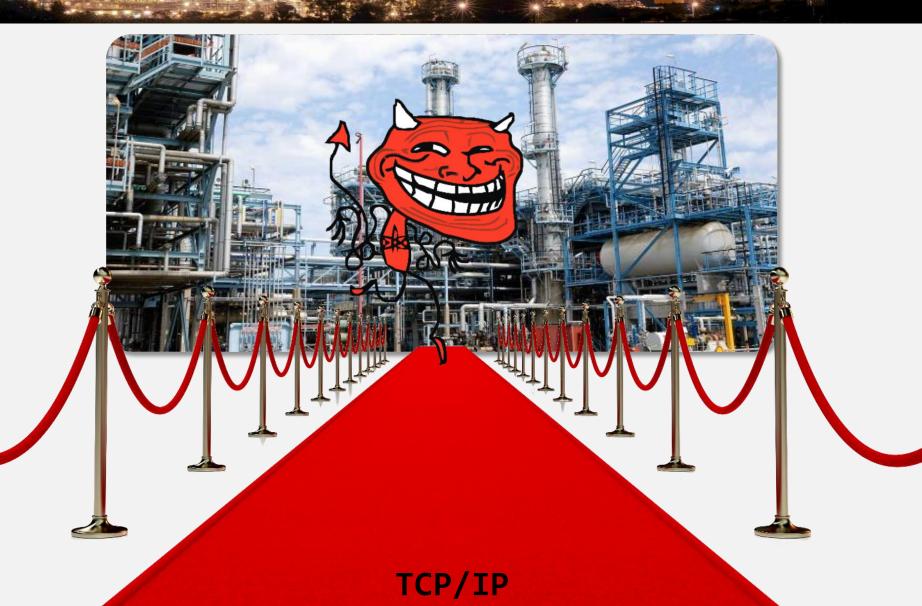






Postamble

State-of-the-art of ICS security





SCADA hacking can be more sophisticated than simply blowing, breaking and crashing

• Espionage attacks matter! They hurt later

Better understanding what the attacker needs to do and why

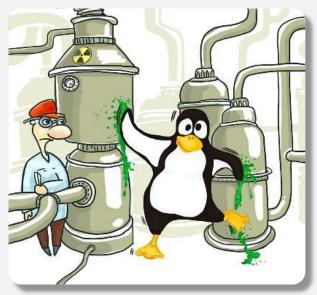
- Eliminating low hanging fruits
- Making exploitation harder
- Making cost of attack exceeding cost of damage

Look for the attacker

- Wait for the attacker where she has to go
- Process control stage is done on live process







Thank you

Marina Krotofil marina.krotofil@tuhh.de

Damn Vulnerable Chemical Process

TE: http://github.com/satejnik/DVCP-TE **VAM:** http://github.com/satejnik/DVCP-VAM